



PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

April 15, 2005

Applicant : Hiroshi KAWAURA

For : METHOD FOR FORMING CVD FILM

Serial No. : 10/692 655 Group: 1762

Confirmation No.: 9922

Filed : October 24, 2003 Examiner: Meeks

Atty. Docket No.: Ishii Case 20

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

In response to the Office Action dated December 16, 2004,
please amend the above-identified application as follows:

(Please see following pages.)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service with
sufficient postage as first class mail in an envelope
addressed to: Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450, on April 15, 2005.


Terryence F. Chapman

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